

# Photoresponse Measurements of Monolayer WSe<sub>2</sub>/MoSe<sub>2</sub> In-plane Heterostructure by an Optically-excited Multiprobe method

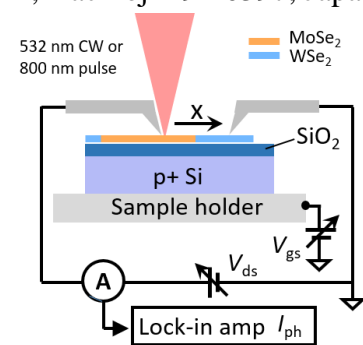
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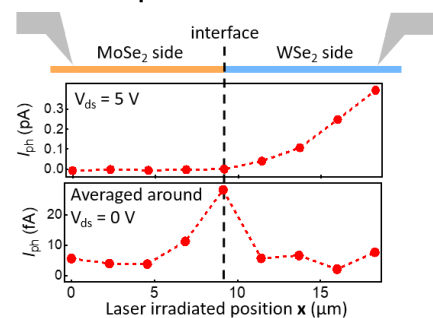
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In recent years, transition metal dichalcogenides (TMDC) family such as MoS<sub>2</sub> and WSe<sub>2</sub> has attracted much attention due to their remarkable optoelectronic properties. Studying band arrangement, optical/electrical characteristics, and transient carrier dynamics is absolutely necessary. An effective approach is to apply multiprobe (MP) STM techniques, in which multiple tips are used to measure, for example, transport characteristics between two desired points, repeatably. However, the simultaneous use of MP techniques with laser technology has not been realized because of the complexities and the handling difficulties.

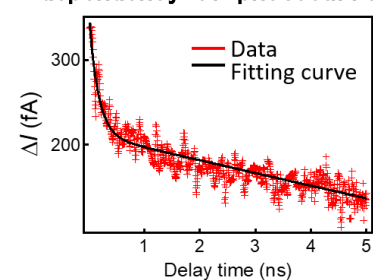
Here, we present a microscopy method that we have developed by combining MP techniques with optical methods. To achieve the experiment, we integrated optical zoom lens above the MP-STM system, which is used for monitoring probe/sample arrangement as well as for laser positioning and focusing with  $\sim\mu\text{m}$  precision. As shown in Fig.1, two c-AFM cantilevers are placed on both sides of a monolayer WSe<sub>2</sub>/MoSe<sub>2</sub> in-plane heterostructure grown on a SiO<sub>2</sub>/Si substrate as pseudo-FET structure. As shown in Fig.2, the spatial distribution of photocurrent ( $I_{\text{ph}}$ ) vs drain-source voltage ( $V_{\text{ds}}$ ) was measured across the MoSe<sub>2</sub>/WSe<sub>2</sub> interface by changing the focusing spot position. As a result, we were able to visualize the band structure including the schottky barrier of probe-sample interface and band shift on MoSe<sub>2</sub>/WSe<sub>2</sub> interface. Next, we show the time-resolved measurement realized by the OPP-MP spectroscopy we have developed. The dynamics of photocarriers we have observed in the experiments by using femtosecond pulsed laser with a pulse width of  $\sim 150$  fs. One of the results is shown in Fig.3. On WSe<sub>2</sub> region, four wide range lifetimes were obtained by fitting the signals with exponential functions ( $\tau_1 \sim 24$  ps,  $\tau_2 \sim 200$  ps,  $\tau_3 \sim 20$  ns, and  $\tau_4 = 500$  ns  $\ll$ ). This technique is expected to play an important role in the researches to develop advanced functional devices with microscopic structures.



**Fig. 1 Diagram of photo-excited multiprobe measurement**



**Fig. 2 Irradiating spot position dependency of photocurrent**



**Fig. 3 Time resolved spectrum on WSe<sub>2</sub> region**